

Radiation damage effects in the LHCb Vertex Locator

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on behalf of the LHCb VELO group

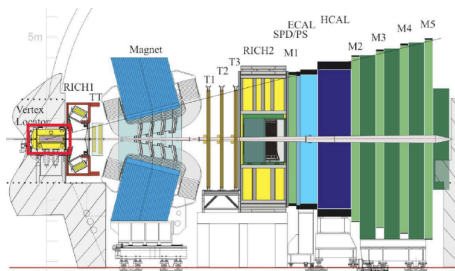
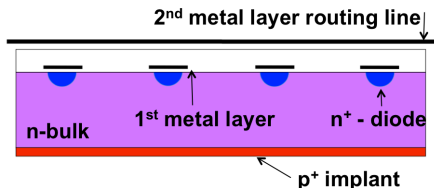
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The LHCb Vertex Locator

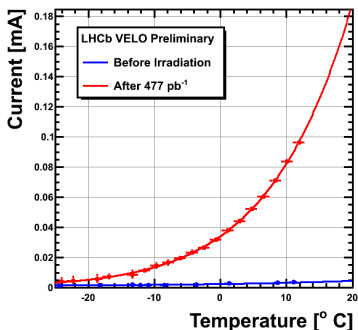
- The **LHCb Vertex Locator** (VELO) is the closest sub detector to the beam at the LHC → **8 mm** at closest point
- Two retractable halves
- 84 sensors, of which 82 are n^+ -on-n and 2 are n^+ -on-p
- 42 R sensors and 42 ϕ sensors



- 300 μm silicon at -8°C
- Oxygenated
- Double metal layer
- Designed to cope with LHC radiation environment
 $\sim 6 \text{ fb}^{-1}$ delivered luminosity

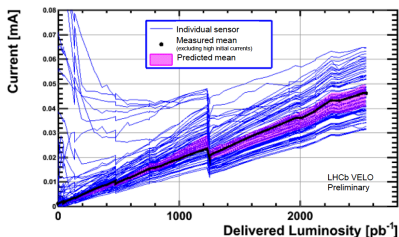
Effective bandgap and current increase

- Measure the **effective bandgap** from exponential fit to leakage currents:



$E_g = 1.16 \pm 0.06$ (eV) at 2.7 fb^{-1}
c.f. 1.21 eV from A. Chilingarov

- Increase in bulk current with fluence proportional to delivered integrated luminosity:

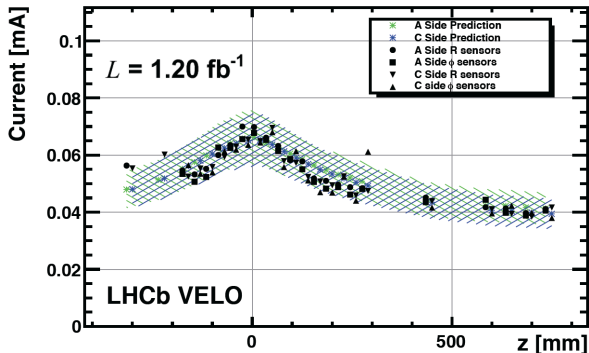


All sensors at 150 V and -8°C

- Good agreement with MC predictions
→ also seen in 2012 at 8 TeV

Fluence predictions

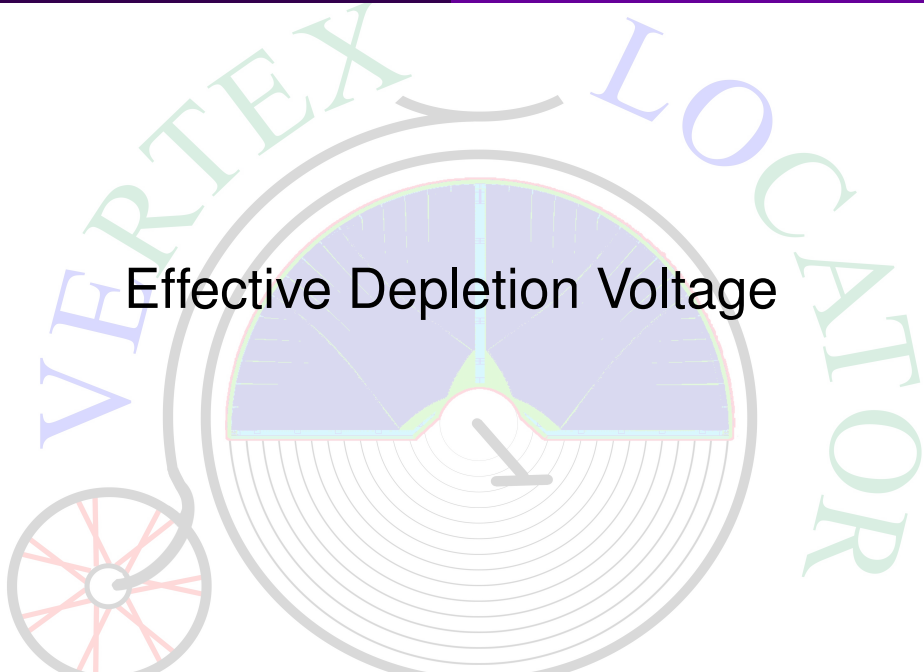
- Compare current measurements to MC predictions sensor by sensor:



Good agreement further justifies our understanding of the fluences received by the VELO

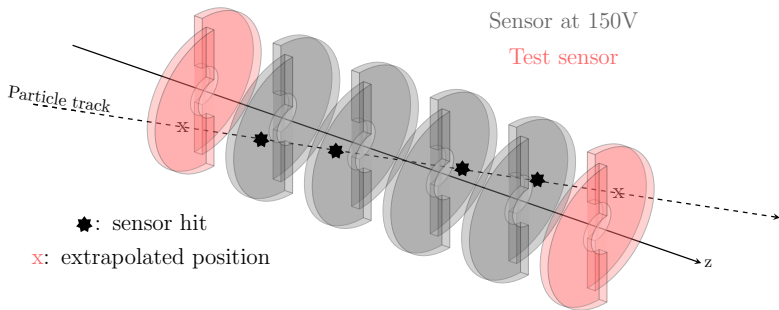
→ use MC predicted fluences in several of the following studies

Effective Depletion Voltage



Effective depletion voltage 1

- Depletion voltage of sensors measured during assembly using C-V scans
- Cannot be repeated after installation so use **dedicated data taking periods** every 3-4 months

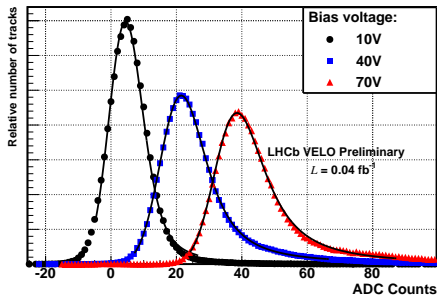


Method: extrapolate tracks to test sensor and determine amount of charge collected

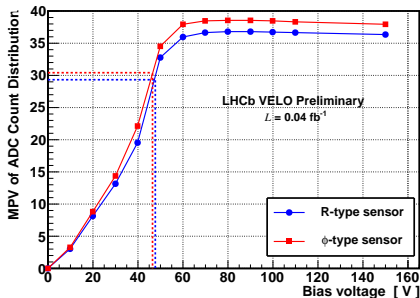
Effective depletion voltage 2

- Pattern varied to collect data at each sensor across a range of voltages

Fit MPV of ADC distribution...



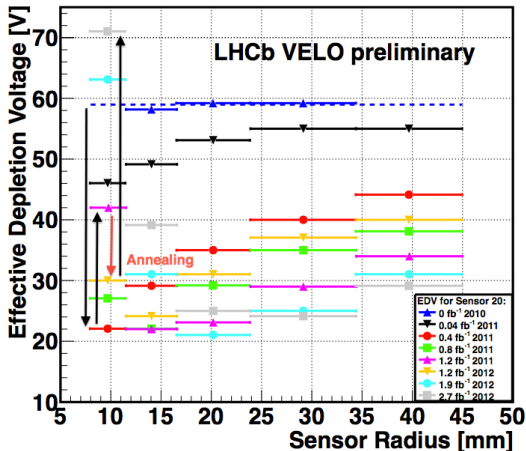
...and plot vs voltage



- Effective Depletion Voltage (EDV) is defined as the voltage at which the MPV is 80% of the maximum

EDV vs fluence 1

Plot **change in EDV** for a single n^+ -on- n sensor in bins of radius for different delivered luminosities:

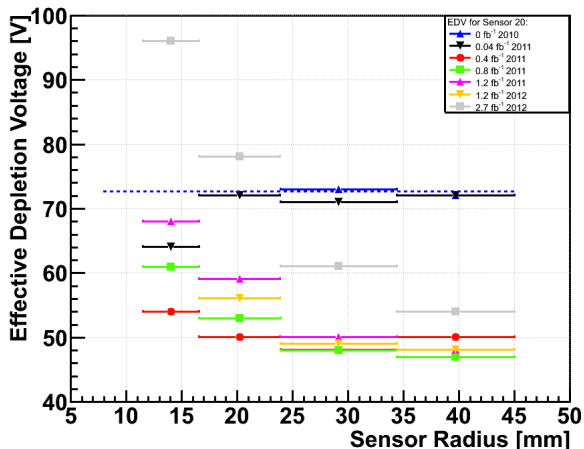


Conclusions:

- EDV decreases with fluence before type-inversion
- EDV increases with fluence after type-inversion
- Type-inversion starts in inner radial regions

EDV vs fluence 2

Change in EDV for a single n^+ -on-p sensor in bins of radius for different delivered luminosities:

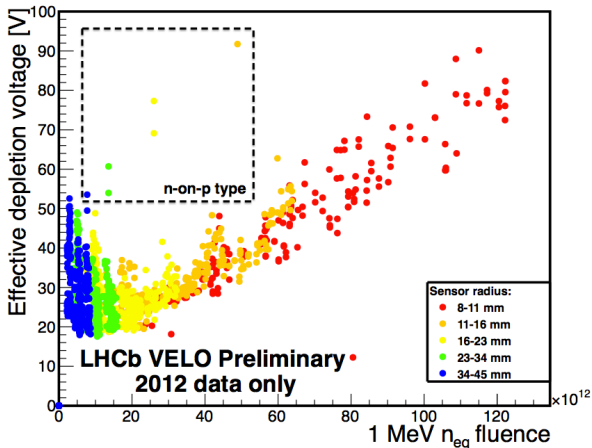


Conclusions:

- EDV decreases with fluence initially as in n^+ -on-n type
- EDV then increases with fluence rapidly
- Minimum EDV point is much higher $\sim 45V$

EDV vs fluence 3

Plot change in EDV versus fluence for all sensors:



Conclusions:

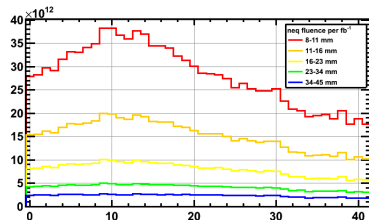
- Minimum observed EDV of ~ 18 V before type-inversion
- Type-inversion occurs at $\sim 15 \times 10^{12}$ MeV n_{eq}
- n^+ -on-p sensors appear to have a shorter lifetime before type-inversion

EDV extrapolations: sensor by sensor

- Fit to EDV vs fluence plot and extrapolate results to 3.6 fb^{-1}

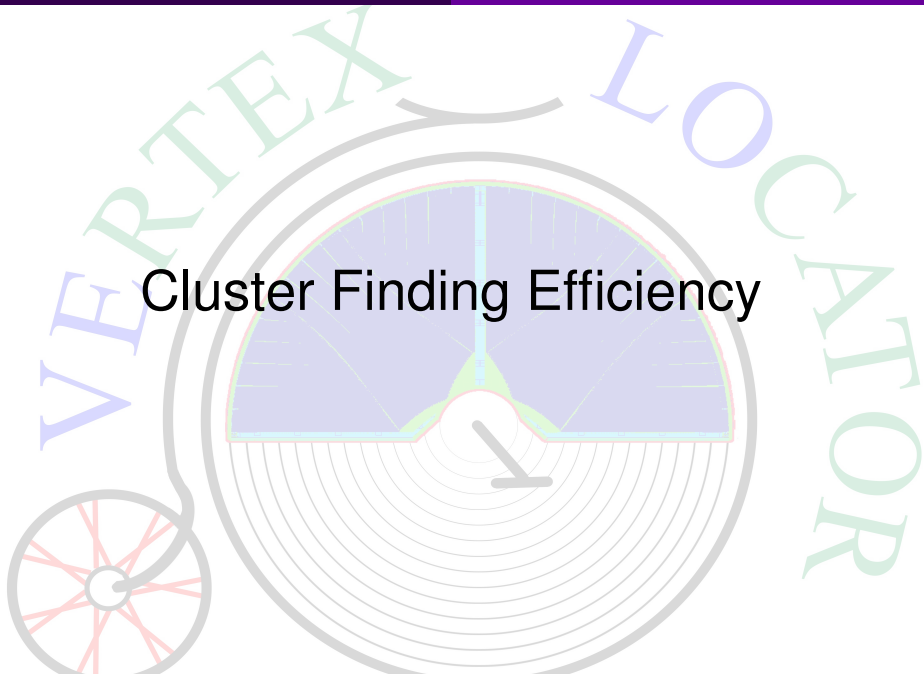
Sensor	Max EDV at 3.5 fb^{-1}
0	241
4	122
5	128
6	127
7	131
8	134
9	145
10	145
11	140
12	138
13	143
14	141
15	132
16	132
17	130
18	125
19	122

120-129V, 130-139V, 140-149V



Predicted fluence vs sensor number

- Highest EDVs are centred around the interaction point
- EDV approaching current operating voltage (150 V) → change before the end of the year

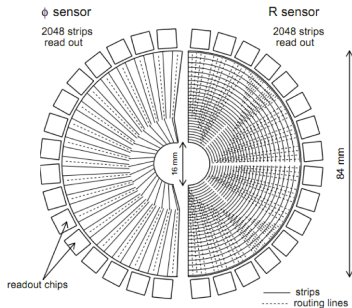
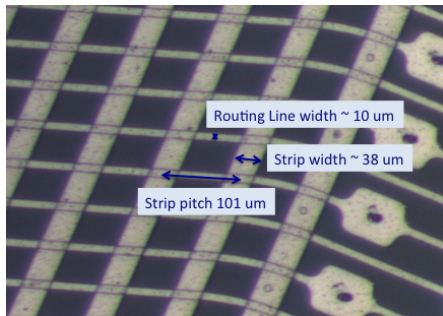


Cluster Finding Efficiency

- A key aspect of VELO physics performance is the ability to efficiently find and reconstruct **clusters**
- A cluster is defined as one or more adjacent silicon strips with charge above a particular threshold
- **Cluster Finding Efficiency** (CFE) is therefore the percentage of tracks at a particular point in the sensor where a cluster is obtained at the track extrapolation point
- Typically measured using regular dedicated scans, but can also be derived from physics data

Second metal layer

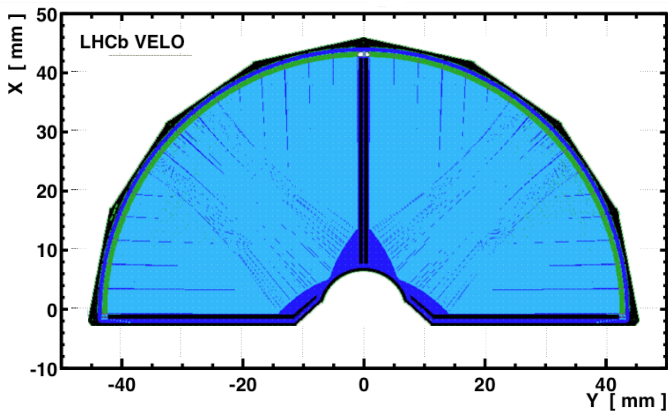
- 1st metal layer capacitively couples to strips
- 2nd metal layer carries signal to read-out electronics



- Routing lines are **perpendicular** to strips in R-sensors and **parallel** to strips in ϕ -sensors
- Charge **capacitively couples** to routing lines in R-sensors and reduces CFE

2D CFE plots

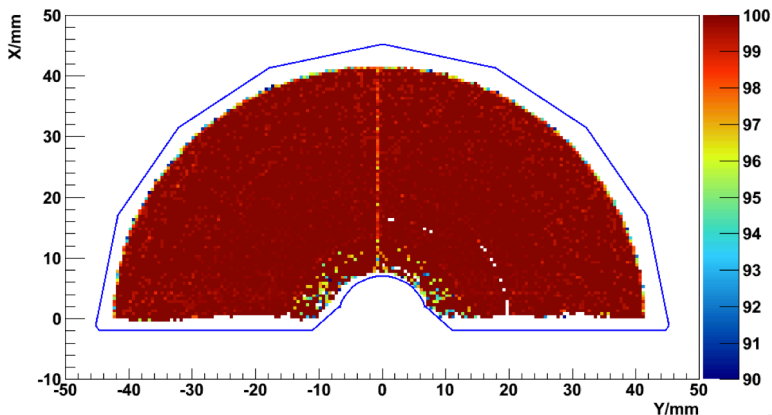
- Map of routing lines in an R-type sensor:



- Light parts indicate absence of routing lines

2D CFE plots

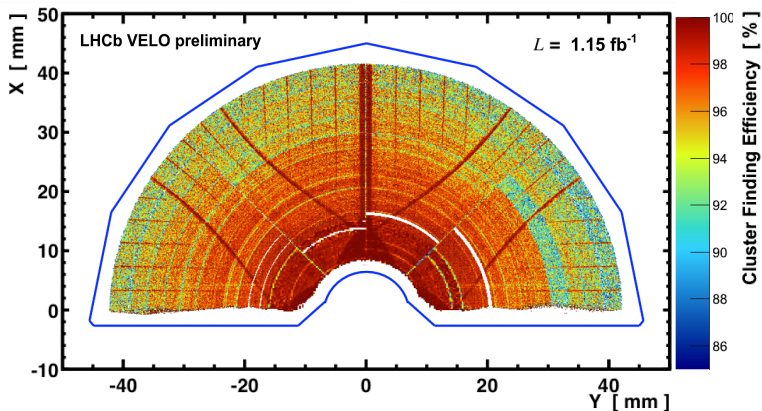
- Plot CFE in x and y bins:



- Early March 2011, after 40 pb^{-1}
 → CFE is $\sim 100\%$ in all regions of sensor

2D CFE plots

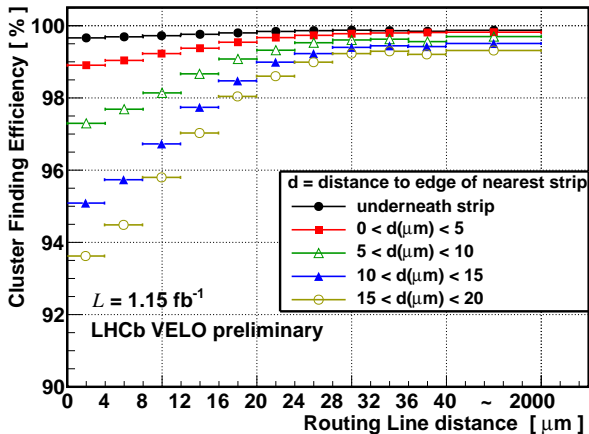
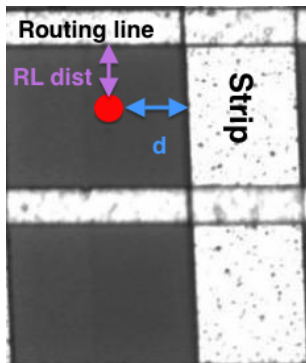
- Repeat after 1.15 fb^{-1} (Oct 2011) delivered integrated luminosity:



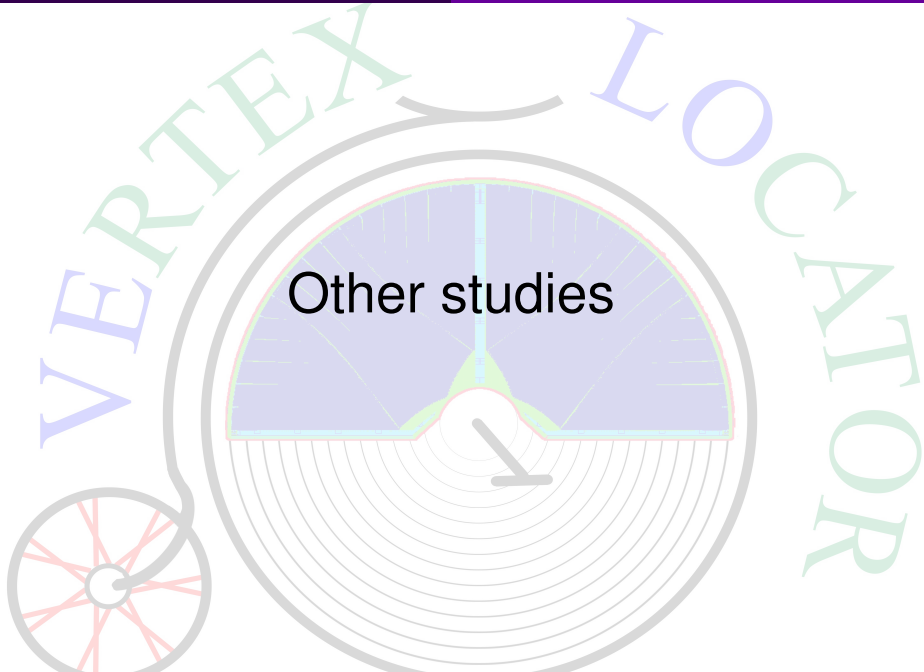
- CFE drops with fluence, especially in outer radial regions
- High efficiency in **absence of routing lines**

Routing line and strip distance dependence

- CFE is worst in regions far away from strips and close to routing lines (shown here for 2011 data - known to be the same in 2012):

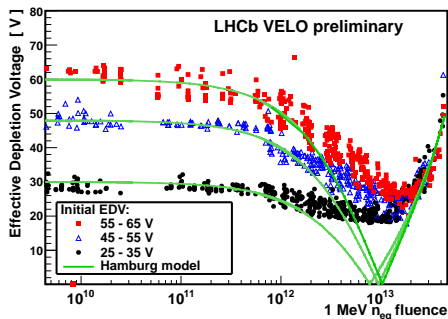
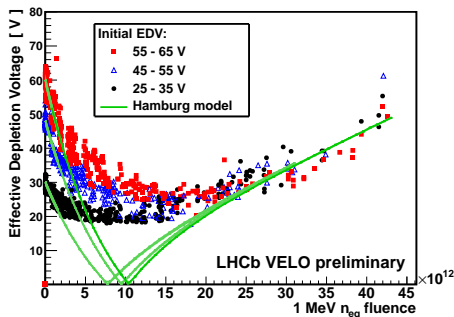


- No measurable effect on tracking efficiency



Hamburg Model comparison

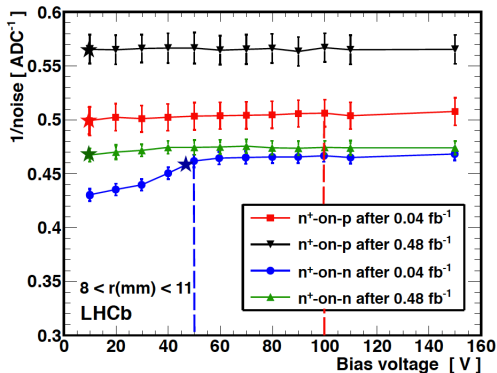
- Compare results to Hamburg Model (for 2011 data only):



- Good agreement at low and high fluences
- Discrepancy around type-inversion point due to finite charge collection time
- Important to predict evolution of depletion voltage for future operations

Noise vs Voltage 1

Can also take regular noise scans without requiring beam

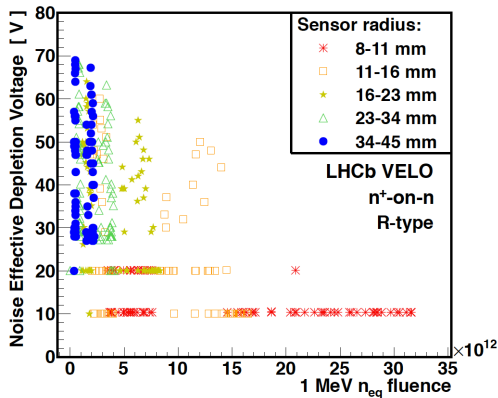


- Under-depleted sensors have higher capacitance
- Depleted sensors have lower capacitance due to depleted region
- Noise proportional to capacitance
→ noise decreases as sensor approaches type inversion point

- Not applicable for n⁺-on-p and type-inverted sensors due to direction of growth of depleted region
- Dashed lines represent initial depletion voltage

Noise vs Voltage 2

Define **Noise Effective Depletion Voltage** (NEDV) as voltage at which $1/\text{noise}$ is 80% of maximum

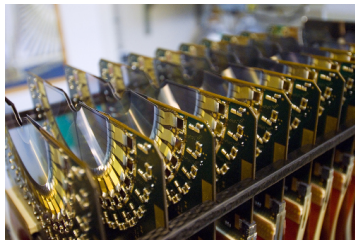
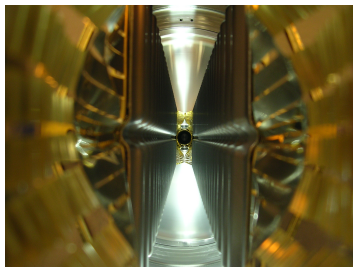


- Plot vs fluence for all sensors, similarly to EDV
- Sensitive to lower voltages than the EDV method
- Excellent agreement with EDV in predicting regions which have type-inverted

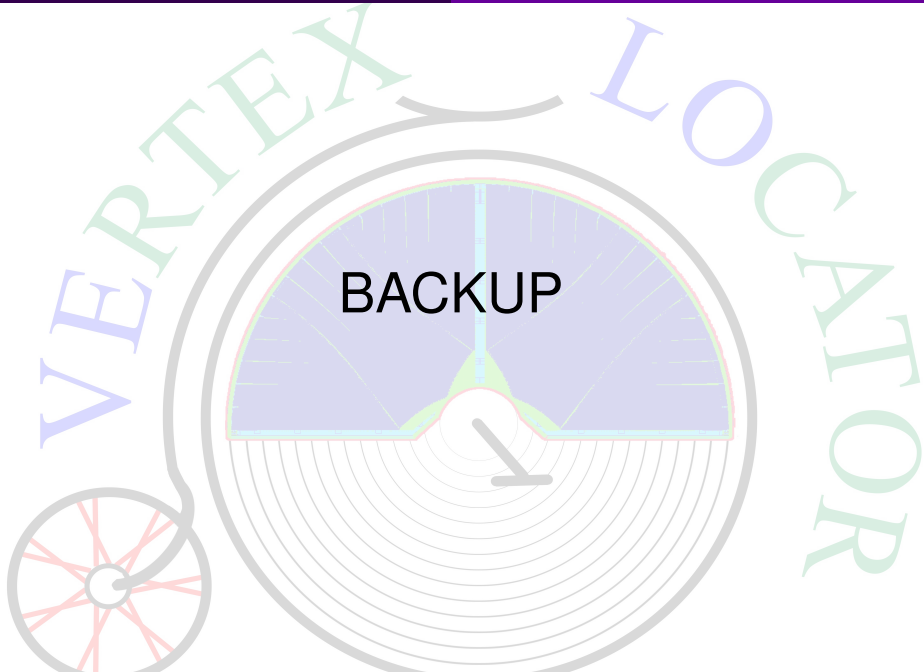
NEDV indicated by stars on previous slide for illustration

→ good agreement with initial depletion voltage

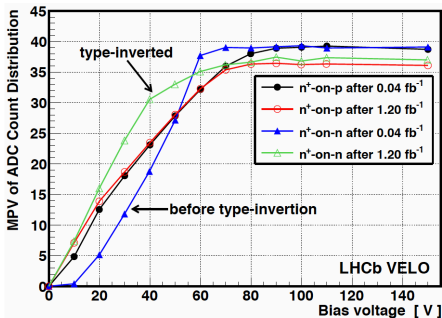
Summary



- Radiation damage effects are studied with several methods
- Change of depletion voltage with fluence agrees well with expectations
- Large CFE decrease due to second metal layer effect observed in some regions of R-sensors
- Currently **no significant effect** on physics performance
- Studies ongoing and in the process of moving towards publication



MPV vs voltage



- For n^+ -on-n depletion region grows from the back plane of the sensor
- For n^+ -on-p depletion and n^+ -on-n after depletion region grows from the strip side of the sensor
- Accounts for the different shape of the curves

Minimum EDV

- Observe a minimum EDV of ~ 18 V
- Due to the slow drift of the charge in the low electric field combined with the fast shaping of the Beetle chip
- Electron drift speed: $\sim 9 \mu\text{m/ns}$ at 18 V, Beetle shaping time: $\sim 20\text{ns}$
 - within shaping time only 60% of electrons reach electrode (+ a small amount from other contributions)
- Require 80% of signal to measure EDV

Further information on effective band gap

- Follow up article on E_g from: [A. Chilingarov 2](#)
- Do not expect a direct comparison between E_g quoted within and the experimentally determined value

CFE vs voltage

Table 4: The CFE change, $\Delta CFE_v = CFE_{V=150} - CFE_{V=80}$, averaged over all R-type sensors.

Delivered Luminosity	$\Delta CFE_v = CFE_{V=150} - CFE_{V=80}$ (%)				
	8-11mm	11-16mm	16-23mm	23-34mm	34-42mm
0.426 fb^{-1}	-0.09 ± 0.09	-0.19 ± 0.02	-0.30 ± 0.01	-0.76 ± 0.03	-1.84 ± 0.19
1.220 fb^{-1}	-0.03 ± 0.28	-0.06 ± 0.02	-0.21 ± 0.02	-0.57 ± 0.04	-1.15 ± 0.40
1.912 fb^{-1}	0.12 ± 0.11	0.15 ± 0.06	-0.15 ± 0.05	-0.85 ± 0.11	-1.49 ± 0.34

- CFE decrease has been found to depend on voltage
- Therefore any increase to account for increasing depletion voltages should be carefully considered
- However dependence appears to disappear for n^+ -on-p sensors and n^+ -on-n sensors after type-inversion